

80/564021

1AP20 Rec'd PCT/PTO 09 JAN 2006

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

<b>In re Application of:</b>	<b>Gripp, Keipke</b>
<b>Application No.:</b>	<b>Not Yet Assigned</b>
<b>Filed:</b>	<b>Concurrently Herewith</b>
<b>For:</b>	<b>Holder For Flat Workpieces, In Particular, Semi Conductor Wafers for Mechanochemical Polishing.</b>
<b>Examiner:</b>	<b>Not Yet Assigned</b>
<b>Group Art Unit:</b>	<b>Not Yet Assigned</b>

Mail Stop PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Docket No.: H01.2-13066-US01**

**Preliminary Amendment**

This preliminary amendment is submitted with this national stage filing under 35 U.S.C. 371 from PCT/EP2003/07376 with an International filing date of July 9, 2003.

If an extension of time is required to make this response timely and no separate petition is enclosed, Applicant hereby petitions for an extension of time sufficient to make the response timely. In the event that this response requires the payment of government fees and payment is not enclosed, please charge Deposit Account No. 22-0350.

Please amend the application as follows:

Amendments to the specification begin on page 2.

Amendments to the claims begin on page 5.

Remarks begin on page 13.